ARTIS

GEMCMSIGEMCMV

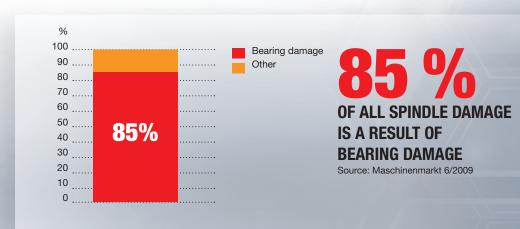
MACHINE PROTECTION COLLISION DETECTION



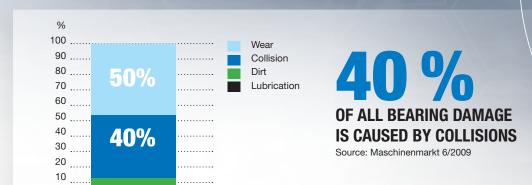
WHY MACHINE PROTECTION?

Nowadays, machines are more and more complex, dynamic and fragile. Production downtimes cause high costs and loss of sales. What is more, company image damage or loss of customers are imminent if planned deliveries are not made on schedule.

CAUSES FOR SPINDLE DAMAGE



CAUSES FOR BEARING DAMAGE



PROBLEM

- Collisions between moving axis and machine element
- Careless manual movement of the axes
- Incorrect entries
- Clamping of wrong tools
- Allowance fluctuations of the workpiece
- Incorrect clamping of the workpiece
- Tool overload (e.g. chip jam)

CONSEQUENCES

- High costs for repair and spare parts
- Possible loss of machine accuracy
- Unplanned downtimes
- Loss of production
- Increase of insurance rates and deductibles

REQUIREMENTS

- Fast collision detection
- Fast stop of the moving axis/axes
- Indication and logging of the event

100

90

- Evaluation of event and graphic data
- Weak point analysis based on the stored data

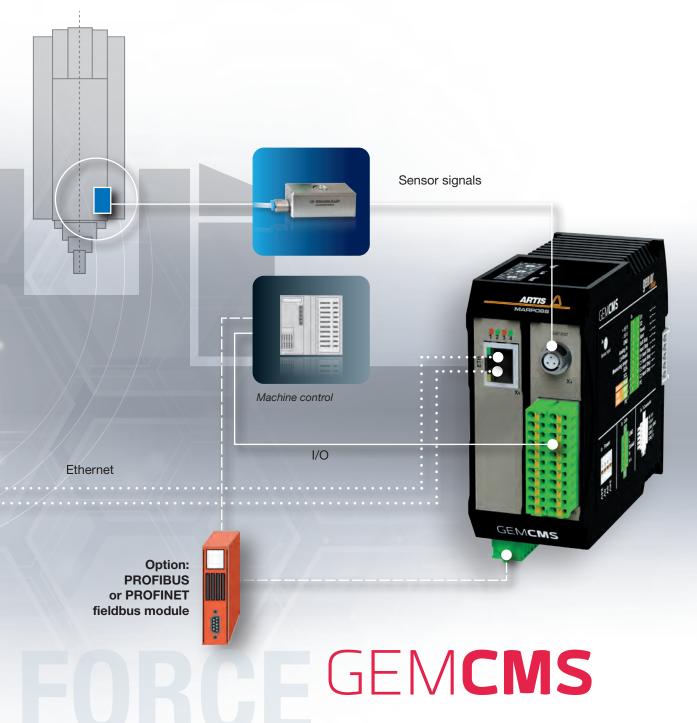
SOLUTION: MODULAR MACHINE SAFETY USING THE SUITABLE INTELLIGENT MONITORING SOLUTION



- For use with all machine types, robots, assembly units etc.
- Simple machine integration, independent of machine controls
- Choice based on requirements (GEMCMV or GEMCMS)
- Permanent monitoring always active
- Event memory: date and time of limit violations
- Tracking and analysis of stored entries
- Fast alarm output for stopping the machine axis/axes
- Can be operated stand-alone or in combination with GENIOR MODULAR

GEMCMS STAND-ALONE

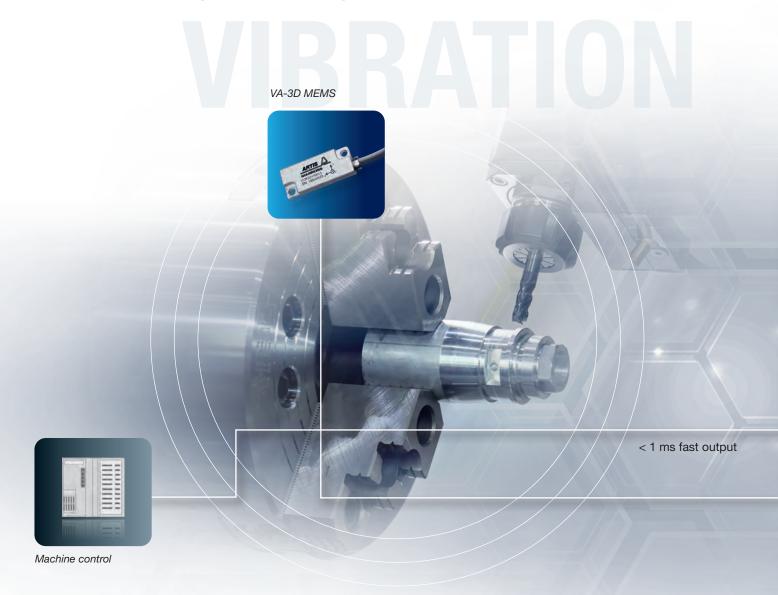


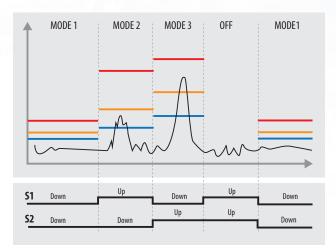


SPECIAL FEATURES

- Compact module for simple integration into the control cabinet
- Sensor connection to the integrated charge amplifier
- Additional charge amplifiers allow sensor distances of more than 20 m
- Ethernet connection to WINDOWS or LINUX (SIEMENS TCU only) systems with installed GEMCMS visualization software
- Simple display and operation via the 4.3" IPC4 system similar to the BRANKAMP CMS system
- Use of tool-related limits (ToolPlus) via PROFINET or PROFIBUS fieldbus modules
- Secure storage of all events in the event memory

GEMCMV STAND-ALONE





GEMCMV operating modes

GEM**CMV** detects dynamic collisions via the connected acceleration sensors. If the defined hard stop limit is violated, an alarm output is set in < 1 ms. This prevents or at least minimizes damage to machines and lines.

SPECIAL FEATURES

- Compact module for simple integration into the control cabinet
- Sensor connection for 1- to 3-axes acceleration sensors with standard IEPE interface
- Ethernet connection to WINDOWS or LINUX (SIEMENS TCU only) systems with installed GEMCMV visualization software
- Secure storage of all events in the event memory
- 3 different operating modes
- 3 different limits per mode
- Fast alarm messages (< 1ms)

Warning

Soft stop Hard stop





GENIOR MODULAR PROCESS MONITORING SIMPLE INTEGRATION

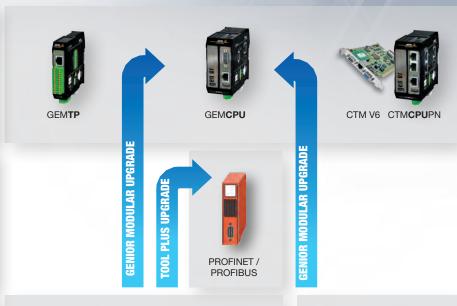


MODULAR DESIGN

PROCESS AND CONDITION MONITORING

TOOL PLUS MONITORING

BASIC FUNCTION





Dynamic collision **GEMCMV**



Quasistatic and dynamic collisions GEM**CMS**



Vibration monitoring GEM**VM**



genior

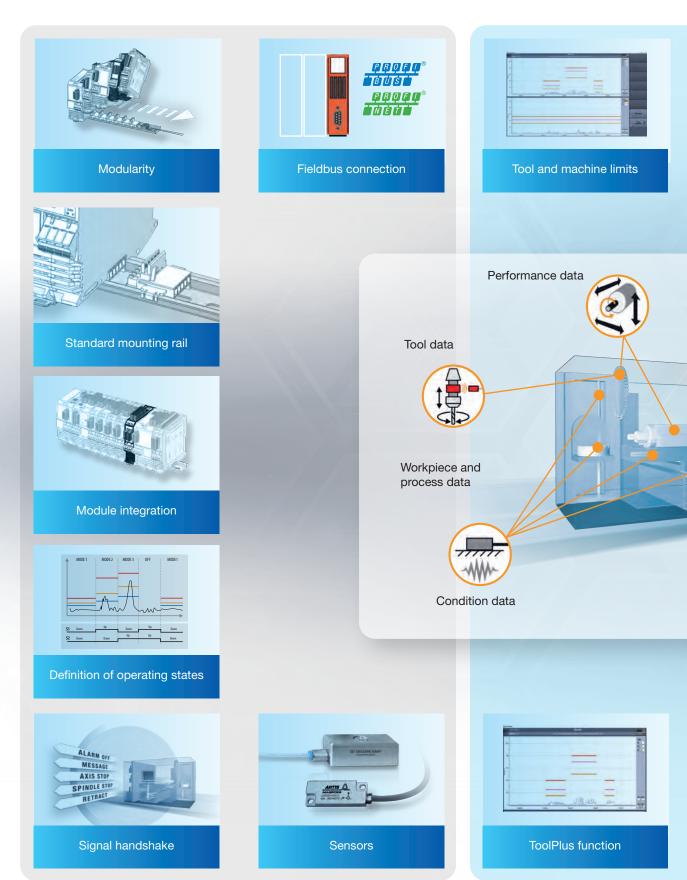
MODULAR PROCESS MONITORING SYSTEM

- All modules can be assembled on a standard mounting rail
- Module connection via T-connector
- Up to 10 measurement channels and up to 16 measurement signals per CPU can be processed in real time
- Visualization via a plug-in for GENIOR MODULAR MultiView for WINDOWS and LINUX (for SIEMENS TCU systems)

OVERVIEW

MACHINE INTEGRATION

MONITORING STRATEGIES



GENIOR MODULAR DATA MANAGEMENT





